

0557-4909-3

*RESPONSE UNDER 37 CFR 1.116-
EXPEDITED PROCEDURE EXAMINING
GROUP 1753

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF

KAZUNORI ITO ET AL

SERIAL NO: 09/498,375

FILED: FEBRUARY 4, 2000

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: EXAMINER: MCDONALD, R. G.

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: GROUP ART UNIT: 1753

FOR: OPTICAL DEVICE SUBSTRATE
FILM-FORMATION APPARATUS,
OPTICAL DISK SUBSTRATE FILM-
FORMATION METHOD, SUBSTRATE
HOLDER MANUFACTURE METHOD,
SUBSTRATE HOLDER, OPTICAL DISK
AND A PHASE-CHANGE RECORDING TYPE
OF OPTICAL DISK

AMENDMENT

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

SIR:

In response to the Official Action mailed January 14, 2003, please amend this
application as follows:

IN THE CLAIMS

Please amend Claims 1, 6, 11, 15, 19 and 73 to read as follows:¹

1. (Twice Amended) An optical disk substrate film-formation apparatus which
manufactures an optical disk by forming a thin film on the surface of a substrate, said
apparatus comprising:

a substrate holder which fixes said substrate during the formation of said film,

¹A marked-up copy of the changes made to these claims is attached.

B
12/1 w.m.
4/23/03
(N.E.)

Entered
Per CFA
Request
5/20/03
w.m.

B1